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Amendment to the Claims:

This listing of claims replaces all prior versions, and listings, of claims in the application:

1. (currently amended) A method comprising:

applying carbon dioxide to a surface of a reticle; and

forming a solid carbon dioxide layer on the surface of the

reticle at a temperature below a sublimation temperature of

carbon dioxide, the solid carbon dioxide layer preventing

particles from contacting the surface of the reticle; and

spraying the surface of the reticle with carbon dioxide inside a lithography tool.

- 2. (original) The method of Claim 1, wherein said applying comprises spraying the surface of the reticle with carbon dioxide and removing particles from the surface with carbon dioxide snow.
- 3. (original) The method of Claim 1, wherein said applying comprises spraying carbon dioxide snow at a grazing angle with respect to the surface of the reticle.
- 4. (original) The method of Claim 1, further comprising cooling the reticle to a temperature below a sublimation

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temperature of carbon dioxide before said forming a solid carbon dioxide layer on the surface of the reticle.

- 5. (original) The method of Claim 1, wherein said forming a solid carbon dioxide layer on the surface of the reticle comprises spraying carbon dioxide snow at a substantially 90 degree angle with respect to the surface of the reticle.
- 6. (original) The method of Claim 1, further comprising: enclosing the reticle with the solid carbon dioxide layer in a carrier; and

maintaining a temperature around the reticle below a sublimation temperature of carbon dioxide.

- 7. (currently amended) The method of Claim $\underline{6}$ \pm , further comprising removing the carrier and inserting the reticle with the solid carbon dioxide layer in a lithography tool.
- 8. (original) The method of Claim 1, further comprising raising a temperature around the reticle above a carbon dioxide sublimation temperature.

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- 9. (original) The method of Claim 1, further comprising removing the solid carbon dioxide layer from the surface of the reticle.
- 10. (original) The method of Claim 1, further comprising spraying the surface of the reticle with carbon dioxide inside a lithography tool.
- 11. (original) The method of Claim 1, further comprising reflecting radiation off the surface of the reticle in a lithography tool.
- 12. (original) The method of Claim 1, further comprising reflecting extreme ultraviolet radiation off the surface of the reticle in a lithography tool.

13-17. (canceled)

18. (new) A method comprising:

spraying carbon dioxide to remove particles on a surface of a reticle;

cooling the reticle to a temperature below a sublimation temperature of carbon dioxide;

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forming a solid carbon dioxide layer on the surface of the cooled reticle to prevent particles from contacting the surface of the reticle;

warming the reticle to sublimate the solid carbon dioxide layer; and

spraying gas to remove particles on the surface.

- 19. (new) A method for cleaning a surface of a reticle inside a lithography tool wherein the improvement comprises spraying the surface of the reticle with carbon dioxide.
 - 20. (new) A method comprising:

placing a pellicle over a reticle;

applying carbon dioxide to a surface of the pellicle;

forming a solid carbon dioxide layer on the surface of the pellicle at a temperature below a sublimation temperature of carbon dioxide to prevent particles from contacting the surface of the pellicle; and

removing the pellicle from the reticle.